



500.37328CX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): YOKOGAWA, et al  
Serial No.: 09/336,687  
Filed: June 21, 1999  
For: PLASMA PROCESSING SYSTEM AND METHOD  
Group: 1763  
Examiner: L. Alejandro

RECEIVED

AUG 21 2003

TC 1700

**AMENDMENT**

Mail Stop Fee-Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 19, 2003

Sir:

In response to the Office Action dated March 27, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendments to the Claims;

Remarks are included following the amendments; and

An Appendix including corrected Fig. 1 is attached following the

Remarks.